

<b>Search Notes</b> 	<b>Application/Control No.</b>	<b>Applicant(s)/Patent under Reexamination</b>
	10/810,482	KISSLING, ETIENNE
	<b>Examiner</b> John Sipos	<b>Art Unit</b> 3721

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
53	as searched		Shelby J